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DEC 20 2004

PATENT
Customer No. 23494
Attorney Docket No. TI-31620
Application No.: 10/085,753**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:)
)
 TSUGA et al.) Group Art Unit: 1746
)
 Application No.: 10/085,753) Examiner: Michael Komakov
)
 Filed: February 28, 2002)
)
 For: **METHOD AND DEVICE FOR**)
 REMOVING PARTICLES ON)
 SEMICONDUCTOR WAFERS)

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

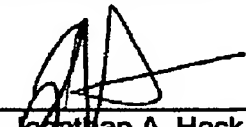
PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three month extension of time to reply to the
Office Action dated June 18, 2004, December 18 being a Saturday.

Please grant any extensions of time required to enter this response and charge
any required fees to the Texas Instruments Incorporated Deposit Account 20-0668.

Respectfully submitted,

Dated: December 20, 2004

By: 
Jonathan A. Hack
Reg. No. 47,623